

Large Optics Diamond Turning Machine (LODTM)

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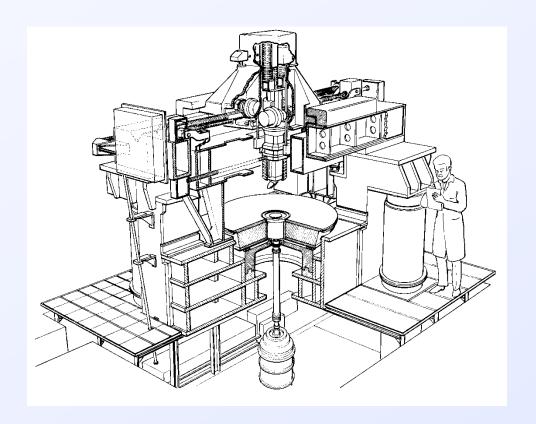
Large Optics Diamond Turning Machine (LODTM)

9-21-09



Keith Carlisle

Large Optics Diamond Turning Machine (LODTM)



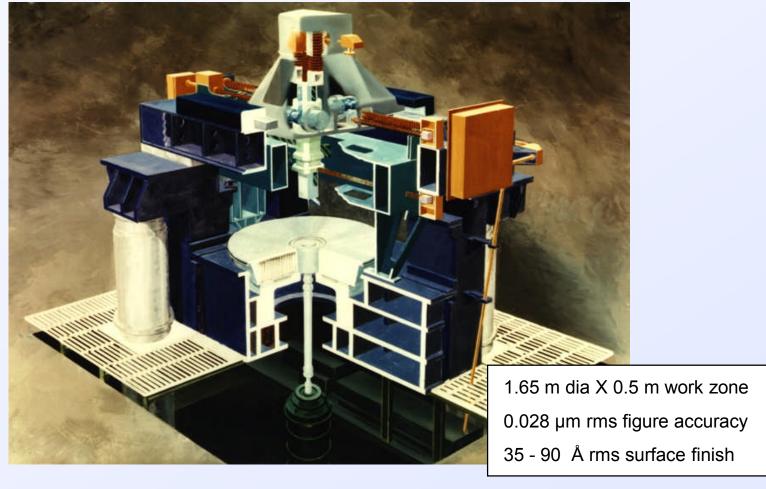


Technologies utilized by LODTM to achieve ALPHA quality SPDT

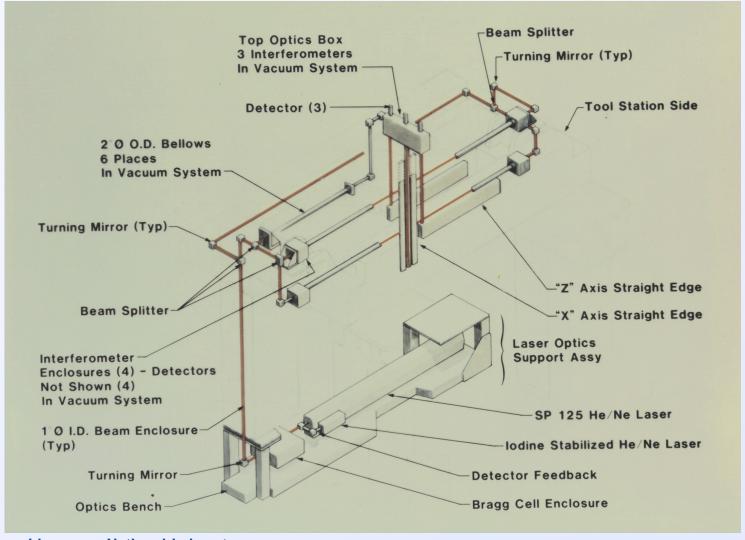
- super invar metrology frame
- precision temperature stabilization of metrology frame (water jacket around metrology frame with 100 gallons/min at ±1/2 m°F over 24 hours)
- precision temperature air shower over LODTM (18,000 CFM at ±5 m°F over 24 hours)
- capstan direct drive using dc servo actuators
- spindle motion compensation in real-time (1.5 ms update)
- straightness and squareness error correction in real-time (1.5 ms update)
- multiple sensors (7 laser interferometers, 4 differential cap. gauges, 1 encoder) used to compute tool-to-part X/Z coordinates in real-time (1.5 ms update)
- evacuated interferometer beam paths



LODTM provided the highest accuracy in precision turning and dimensional metrology for its meter size capacity



LODTM "X" & "Z" Laser Metrology Frame





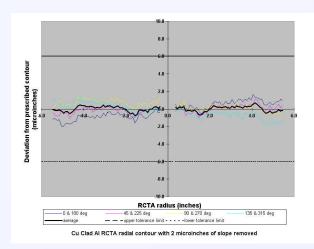
LODTM Preparation for Off Axis Morrors

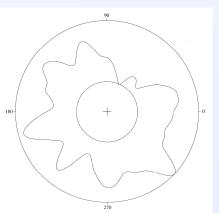


LODTM Diamond Machining an Off Axis Mirror

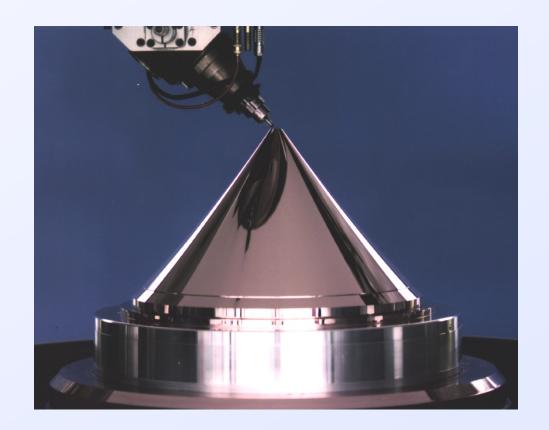


LODTM Diamond Turned & Inspected a Cu-clad RCTA to ALPHA Quality



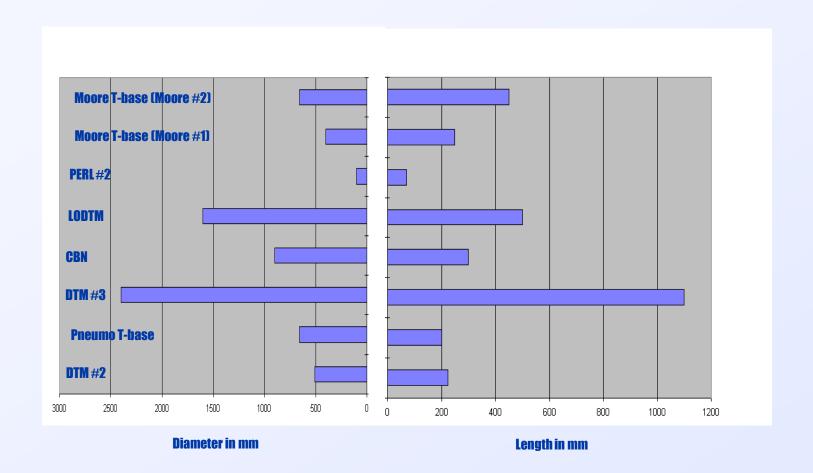


Span from inner to outer circle = 1.1 µinches
Date: 17-September-1998
Centering: Not centered
Filtering: 41.7 UPR





Working volumes for selected LLNL diamond turning machines





Typical contour and surface finish on copper parts for selected LLNL diamond turning machines

